

# Notice of References Cited

Application/Control No.

09/665,111 09/665,911

Applicant(s)/Patent Under  
Reexamination *Nomura et al.*  
~~HOTALING, EDDIE~~

Examiner

Matthew Landau

Art Unit

2815

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## U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,998,810	12-1999	Hatano et al.	257/102
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
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	K	US-			
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## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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## NON-PATENT DOCUMENTS

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